EFS-Web Receipt date: 03/28/2008 10826985 - GAU: 2823

PATENT

OK TO ENTEPONDE 104/29/2008) TENT AND TRADEMARK OFFICE

In re Application of: Luo et.al.

Serial No.: 10/826,985

Filed: April 19, 2004

For: METHODS FOR FORMING PROTECTIVE LAYERS ON SEMICONDUCTOR DEVICE COMPONENTS SO AS TO REDUCE OR ELIMINATE THE OCCURENCE OF DELAMINATION THEREOF AND CRACKING THEREIN

Confirmation No.: 3493

Examiner: J. Stark

Group Art Unit: 2823

Attorney Docket No.: 2269-5565.1US

(2002-1124.01/US)

VIA ELECTORNIC FILING March 28, 2008

RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Examiner:

This Response follows the final Office Action of January 28, 2008, the shortened statutory period for response to which expires on April 28, 2008. This response is being submitted within two months of the mailing date of the final Office Action.